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PATENT

Customer No. 22,852

Attorney Docket No. 07553.0030 (formerly 07363.0010)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Reissue Application of: )

U.S. Patent No.: 5,792,261 )

Inventor: Kiichi HAMA et al. )

Issued: August 11, 1998 )

Serial No.: 09/478,370 )

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For: PLASMA PROCESS  
APPARATUS

Group Art Unit: 1763

Examiner: L. Alejandro Mulero

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GROUP 1700

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**PETITION FOR EXTENSION OF TIME**


Applicants hereby petition for a two-month extension of time to reply to the Office Action of December 31, 2002, thereby extending the period for response through May 31, 2003. A fee of \$410.00 is enclosed.

Please grant any extensions of time required to enter this response and charge any additional required fees to our deposit account 06-0916.

Respectfully submitted,

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Dated: May 21, 2003

By:   
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